



520.41064X00 / NT0550US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): HAMAMATSU, et al.
Serial No.: 10/050,776
Filed: January 18, 2002
For: APPARATUS AND METHOD FOR INSPECTING DEFECTS
Group: 2877
Examiner: M. Stafira
Conf. No.: 9567

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

August 8, 2006

Sir:

In response to the Office Action dated March 8, 2006, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims

Remarks are included following the amendments